



PATENT

Atty. Dkt. No. AMAT/4471.Y1/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zheng, et al.

Serial No.: 09/614,407

Confirmation No.: 1903

Filed: July 12, 2000

For: Method of Application of
Electrical Biasing To
Enhance Metal Deposition

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Group Art Unit: 1753

Examiner: Brian L. Mutschler

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on March 8, 2004 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV33547774US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

3/8/04

Date

Keith M. Tackett

Signature

REQUEST FOR NON-ENTRY OF AMENDMENT

Applicants respectfully request non-entry of the Response to the October 20, 2003 Final Office Action mailed on December 22, 2003.

Respectfully submitted,

Keith M. Tackett

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